

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

HAN CHEOL RYU, ET AL.

Application No.:

Filed:

For: **DISTRIBUTED ANALOG PHASE
SHIFTER USING ETCHED
FERROELECTRIC THIN FILM
AND METHOD OF
MANUFACTURING THE SAME**

Art Group:

Examiner:

Commissioner for Patents
P.O, Box 1450
Alexandria, VA 22313-1450

REQUEST FOR PRIORITY

Sir:

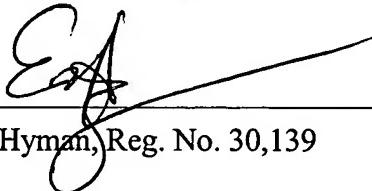
Applicant respectfully requests a convention priority for the above-captioned application, namely:

| COUNTRY | APPLICATION NUMBER | DATE OF FILING |
|---------|-----------------------|----------------|
| Korea | 2003-56847 | 18 August 2003 |

A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP



Eric S. Hyman, Reg. No. 30,139

Dated: March 8, 2004

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